SUPPLEMENTAL APPLICATION DATA SHEET

APPLICATION INFORMATION

Application Number::	<u>10/517,772</u>
Application Date::	<u>12/27/04</u>
Application Type::	REGULAR
Subject Matter::	UTILITY
CD-ROM or CD-R?::	NONE
Title::	<u>SEMICONDUCTOR DEVICE AND ITS MANUFACTURING METHOD</u>
Attorney Docket Number::	263878US2PCT
Total Drawing Sheets::	12

INVENTOR INFORMATION

Applicant Authority Type::	INVENTOR
Primary Citizenship Country::	Japan
Status::	FULL CAPACITY
Given Name::	Kenji
Family Name::	FUKUDA
City of Residence::	Ibaraki
Country of Residence::	Japan
Street of Mailing Address::	Nat'l Institute of Advanced Industrial Sci. & Tech., Tsukuba Central 2, 1-1-1, Umezono Tsukuba-shi
City of Mailing Address::	Ibaraki
Country of Mailing Address::	Japan
Postal or Zip Code of Mailing Address::	305-8568

Applicant Authority Type::	INVENTOR
Primary Citizenship Country::	Japan
Status::	FULL CAPACITY
Given Name::	Junji
Family Name::	SENZAKI
City of Residence::	Ibaraki
Country of Residence::	Japan
Street of Mailing Address::	Nat'l Institute of Advanced Industrial Sci. & Tech., Tsukuba Central 2, 1-1-1, Umezono Tsukuba-shi
City of Mailing Address::	Ibaraki
Country of Mailing Address::	Japan
Postal or Zip Code of Mailing Address::	305-8568

CORRESPONDENCE INFORMATION

Correspondence Customer Number::   22850

REPRESENTATIVE INFORMATION

Representative Customer Number::   22850

DOMESTIC PRIORITY INFORMATION

Application::	Continuity Type::	Parent Application::	Parent Filing Date::
This Application	National Stage of	PCT/JP03/08146	06/26/03

FOREIGN PRIORITY INFORMATION

Application Number:	Country::	Filing Date::	Priority Claimed::
2002-189161	Japan	06/28/02	YES

ASSIGNMENT INFORMATION

Assignee Name::   National Institute of Advanced Indust Sci & Tech

Street of Mailing Address::   3-1, Kasumigaseki 1-chome, Chiyoda-ku
City of Mailing Address::   Tokyo
Country of Mailing Address::   Japan
Postal or Zip Code of Mailing Address::   100-8921